

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/659,624	GOUO, AKIO	
	Examiner	Art Unit	
	Paul D. Kim	3729	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Reviewed Parent Application 09/748,918 US PAT. 6,690,546	7/21/2005	PK
Text Search EAST/NPL (IEEE)	7/21/2005	PK
Consuted by David Shindler (324)	7/28/2005	PK
Consuted by Criag Renner (360)	7/28/2006	PK
Updated Text Search EAST	7/28/2006	PK
PGPub Text Search EAST	1/31/2006	PK

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
PGPub Text Search See attachment		1/31/2006	PK